



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG744504819
Report verification at igi.org

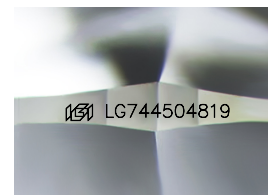
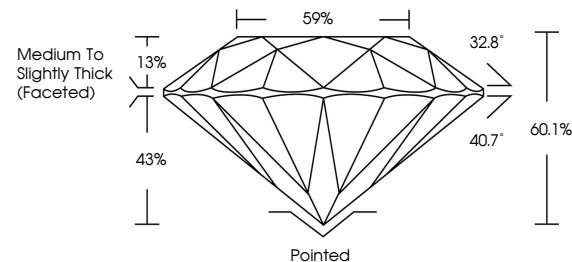
October 31, 2025	
IGI Report Number	LG744504819
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	8.16 - 8.20 X 4.92 MM
GRADING RESULTS	
Carat Weight	2.02 CARATS
Color Grade	D
Clarity Grade	VVS 2
Cut Grade	IDEAL

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	151 LG744504819

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

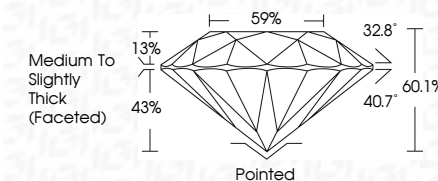
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

LABORATORY GROWN DIAMOND REPORT



October 31, 2025	
IGI Report Number	LG744504819
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	8.16 - 8.20 X 4.92 MM
GRADING RESULTS	
Carat Weight	2.02 CARATS
Color Grade	D
Clarity Grade	VVS 2
Cut Grade	IDEAL



ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG744504819
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.	
Type IIa	



© IGI 2020, International Gemological Institute

FD - 10 20



THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK, BACKGROUND DESIGNS, HOLOGRAM, AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINES.

www.igi.org

October 31, 2025
GI Report No LG744504819
ROUND BRILLIANT

1.16 - 8.20 X 4.92 MM	Corat Weight	2.02 CARATS
	Color Grade	D
	Clarity Grade	VVS 2
	Cut Grade	IDPAL
	Depth	60.1%
	Table	59%
	Grade	Medium to Slightly Thick (Faceted)
	Culet	Pointed
	Polish	EXCELLENT
	Symmetry	EXCELLENT
	Fluorescence	NONE
		4mm (27.440000)

Comments:
This Laboratory Grown Diamond was
created by Chemical Vapor Deposition
(CVD) growth process.